Courses in English

Course Description



Department 06 Applied Sciences and Mechatronics

Course title Scanning Probe Microscopy

Hours per week (SWS) 4

Number of ECTS credits 6

Course objective

After completing this module successfully, students possess or have improved their competencies in the following fields:

They have a profound understanding of fundamental scanning probe techniques;

- They know and are able to describe a selection of advanced scanning probe techniques;

- They can explain feedback mechanisms;

- They can point out the potential and technical limitations of scanning probe techniques in order to develop autonomy for the choice of these techniques for individual needs as advanced users.

Prerequisites Basics in physics, especially solid state physics

Recommended reading

Teaching methods seminaristic teaching with exercises

Assessment methods written exam, 90min

Language of instruction English

Name of lecturer Andreas Ruediger

Email <u>ruediger@emt.inrs.ca</u>

Link

Course content - Brief review of surface and tunneling physics and atomic interaction potentials

Cantilever mechanics and tip-fabrication
ip-sample mechanics: extreme cases

- Ambient atmosphere and vacuum approaches

- Basic modes of operation

-- Scanning tunneling microscopy

-- Contact mode atomic force microscopy (AFM)

-- Intermittent mode AFM

-- Non-contact mode AFM and shear-force AFM

-- Measuring in liquids

- Functionalized modes

-- Conductive AFM

-- Piezoresponse AFM

-- Scanning capacitance and Kelvin Probe

-- Magnetic force microscopy and the hard disc drive

-- Near-field microscopy

-- Tip-enhanced Raman spectroscopy

Remarks only in summer 21